

Title (en)

CLEANING DEVICE FOR RINSING DISPENSING NOZZLES

Title (de)

REINIGUNGSVORRICHTUNG ZUM SPÜLEN VON AUSGABEDÜSEN

Title (fr)

DISPOSITIF DE NETTOYAGE DESTINÉ À RINCER DES BUSES DE DISTRIBUTION

Publication

EP 3318334 A1 20180509 (EN)

Application

EP 16197253 A 20161104

Priority

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Abstract (en)

A cleaning device for rinsing dispensing nozzles, comprising a sealed protection chamber (10); a solvent bath (13) provided to maintain a solvent-saturated atmosphere in the chamber; a sealed inlet (8) for introducing one or more dispensing nozzles (6) into the chamber; a solvent supply system connected to lead a cleaning solvent to rinse a nozzle present in the inlet; and a nozzle drain outlet (11) arranged below the or each inlet, such that cleaning solvent from a nozzle falls into said nozzle drain outlet.

CPC (source: EP)

B05B 15/55 (2018.01); **B05B 15/555** (2018.01)

Citation (applicant)

- US 2013319470 A1 20131205 - KAI YOSHIHIRO [JP], et al
- US 2014283878 A1 20140925 - OOSHIRO KENICHI [JP], et al
- US 2016016208 A1 20160121 - ZHANG FAN [CN], et al
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Citation (search report)

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- [XI] US 2006147620 A1 20060706 - KWON O J [KR], et al
- [X] WO 2011105953 A1 20110901 - HEDSON TECHNOLOGIES AB [SE], et al
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Designated contracting state (EPC)

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Designated extension state (EPC)

BA ME

DOCDB simple family (publication)

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